



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	Attorney Docket No. LAM1P109
Julia S. SVIRCHEVSKI et al.)	Examiner: L. Umez-Eronini
Application No. 09/336,401)	Group Art Unit: 1765
Filed: June 18, 1999)	Date: January 22, 2004
For: POST-PLASMA PROCESSING)	
WAFFER CLEANING)	
METHOD AND SYSTEM)	

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 22, 2004.

Signed:

Diane Schwanbeck
Diane Schwanbeck

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is in response to a non-final Office Action mailed on September 22, 2003. A response to the non-final Office Action was due on December 22, 2003. Accordingly, Applicants concurrently submit a request for a one-month extension of the period for the response. Please enter the following amendments and remarks.

Listing of Claims begins on page 2.

Remarks begin on page 7.

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